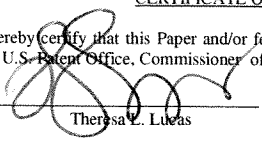


CERTIFICATE OF TRANSMISSION

I hereby certify that this Paper and/or fee is being electronically filed via EFS in the U.S. Patent Office, Commissioner of Patents on **January 23, 2008**.

By


Theresa L. Lucas

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

INVENTOR(S) : Rajasingh Israel, et al.

TITLE : OPTIMAL SILICON DIOXIDE PROTECTION
LAYER THICKNESS FOR SILVER LAMP
REFLECTOR

APPLICATION NO. : 10/633,085

FILED : August 1, 2003

CONFIRMATION NO. : 3209

EXAMINER : Anne M. Hines

ART UNIT : 2879

LAST OFFICE ACTION : November 2, 2007

ATTORNEY DOCKET NO. : LD HQ10695-3
GECZ 2 00083-2-3

MAIL STOP AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT A

Dear Sir:

Responsive to the Office Action mailed November 2, 2007, on the above- referenced patent application, Applicant(s) respectfully request reconsideration of the application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.